

PATENT NUMBER

U.S. UTILITY Patent Application

O.I.P.E.

PATENT DATE

SCANNED LM4 Q.A.

APPLICATION NO. 09/848533	CONT/PRIOR F	CLASS 118-118 134	SUBCLASS 7154	ART UNIT/763 1763	EXAMINER Lund
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Young-Hoon Park

[illegible]

Atomic layer deposition (ALD) thin film deposition equipment having cleaning apparatus and cleaning method

PTO-2040
12/89

ISSUING CLASSIFICATION

[illegible]

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	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
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